

Docket No.: 1592-0163PUS1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Masashi NAKAMURA et al.

Application No.: 10/589,733

Confirmation No.: 2225

Filed: March 22, 2007

Art Unit: 2895

For: VAPOR PHASE GROWTH METHOD

Examiner: A. K. Singal

**RESPONSE TO FINAL ACTION UNDER 37 C.F.R. 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Madam:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated October 1, 2008, finally rejecting claims 1-5, please amend the above-identified U.S. patent application as follows:

**Remarks/Arguments** begin on page 2 of this paper.